

<b>Notice of References Cited</b>	Application/Control No. 10/037,447	Applicant(s)/Patent Under Reexamination EGAN ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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**FOREIGN PATENT DOCUMENTS**

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	N	10--7709	01-1998	JP		
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	HCAPLUS, DN:128:147502, Toba et al., JP 10007709, (1998), abstract only for JP 10-7709.
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	X	 12-12-05

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